PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

in re Application of: Kazuaki EJIRI

Appl. No.: 10/749,599

Art Unit: 2818

Filed: December 31, 2003

Examiner: LEE, Calvin

For:

CHEMICAL MECHANICAL POLISHING

METHOD AND WASHING/RINSING METHOD ASSOCIATED THEREWITH Atty. Docket: IGM-02001

CERTIFICATE OF MAILING

I hereby certify that the foregoing document is being deposited with the United States Postal Service as first class mail, postage prepaid, "Post Office to Addressee", in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on August 9, 2005.

AMENDMENT AND RESPONSE TO OFFICE ACTION

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

This paper is being provided in response to the Office Action dated April 27, 2005, for the above-captioned U.S. patent application.

Amendments to the Claims are listed beginning on page 2 of this paper.

Remarks begin on page 5 of this paper.

It is not believed that extensions of time or fees for net addition of claims are required, beyond those which may otherwise be provided for in documents accompanying this paper. However, in the event that additional extensions of time are necessary, then such extensions of time are hereby petitioned under 37 C.F.R. § 1.136(a), and any fees required for consideration of this paper (including fees for net addition of claims) are authorized to be charged in two originally-executed copies of an Amendment Transmittal Letter filed herewith.